



Attorney's Docket No.: 17-084001 / F51-134741MSW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Izuo Iida  
Serial No. : 09/876,554  
Filed : June 7, 2001  
Title : METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

Art Unit : 2815  
Examiner : N. Richards

**MAIL STOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JULY 2, 2003

Please amend the above-identified application as follows:

RECEIVED  
SEP 29 2003  
TECHNOLOGY CENTER 2800

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

September 23, 2003  
Date of Deposit

Kathryn Lugo  
Signature  
KATHRYN LUGO

Typed or Printed Name of Person Signing Certificate